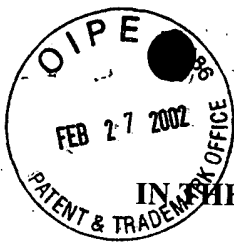


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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshihito OOKAWA, et al.

Serial No.: 09/980,309

Group Art Unit: 1734

Filed: November 30, 2001

Examiner: To Be Assigned

For: PLASMA PROCESSING UNIT, WINDOW MEMBER FOR PLASMA PROCESSING UNIT AND ELECTRODE PLATE FOR PLASMA PROCESSING UNIT

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

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TC 1700

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and copies of the documents cited therein.

It is respectfully requested that each cited document be considered by the Examiner in the above-identified patent application and that each cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Statement is being submitted less than three months after the national stage entry date for this application. (Additionally, a first Official Action has not yet issued for this application.) Therefore, no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,

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